

10/019244

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JC13 Rec'd PCT/PTO 21 DEC 2001

FORM PTO-1449 (Modified) LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	ATTY. DOCKET NO. 1446NP	SERIAL NO. To Be Assigned
	APPLICANT: Prasad Narhar GADGIL	
	FILING DATE: Herewith	GROUP: To Be Assigned

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

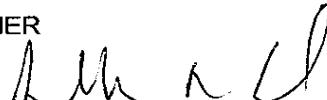
EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPRO.)
AK	4 9 9 3 3 5 7	02/19/91	Scholz	118	715	
AK	5 2 4 2 5 3 0	09/07/93	Batey et al.	156	613	
AK	5 2 5 6 2 0 5	10/26/93	Schmitt, III et al.	118	723	
AK	5 2 8 1 2 7 4	01/25/94	Yoder	118	697	
AK	5 3 1 6 7 9 3	05/31/94	Wallace et al.	427	248.1	
AK	5 3 4 2 6 6 0	08/30/94	Cann et al.	427	577	

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation
0 0 1 5 3 9 0	17.09.80	EPO	—	—	

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

AK	✓	Hurle, D.T.J., "Thin Films and Epitaxy," Handbook of Crystal Growth, Vol. 3, 1994, pp. 606-663.
AK	✓	Jiu, H. et al., "GaAs Atomic Layer Epitaxy in a Rotating Disc Reactor," SPIE, Vol. 1676, 1992, pp. 20-25.

EXAMINER 	DATE CONSIDERED 11/25/03
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<i>ANK</i>	5 8 1 0 9 4 2	09/22/98	Narayanswami et al.	134	7	
<i>ANK</i>	5 8 7 9 4 5 9	03/09/99	Gadgil et al.	118	715	

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

<i>ANK</i>	<input checked="" type="checkbox"/>	McIntosh, F.G. et al., "Silicon Monolayer Growth Using Dichlorosilane and Hydrogen in a Near Atmospheric Pressure Chemical Vapor Deposition Reactor," Thin Solid Films 225, 1993, pp. 183-186.
<i>ANK</i>	<input checked="" type="checkbox"/>	Reid, K.G. et al., "The Role of Gas Phase Decomposition in the Ale Growth of III-V Compounds," North Carolina State University, Electrical & Computer Engineering Dept., Raleigh, NC., pp. 133-138.

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<i>AW</i>	<input checked="" type="checkbox"/>	Sumakeris, J. et al., "Layer-by-Layer Epitaxial Growth of GaN at Low Temperatures," Thin Solid Films, 1993, pp. 244-249.
<i>AW</i>	<input checked="" type="checkbox"/>	Usui, Akira, "Atomic Layer Epitaxy of III-V Compounds: Chemistry and Applications," Proceedings of the IEEE, Vol. 80, No. 10, October 1992, pp. 1641-1653.

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